

10-2901

0400

Atty Dkt. No.  
33766W039

PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#4

Applicant: Lothar Mussmann, et al.

Serial No.: 09/931,162

Examiner: To Be Assigned

Filed: August 17, 2001

Group Art Unit: To Be Assigned

For: Oxygen Storage Material Based on Cerium Oxide, A Process for its Preparation and its Use

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

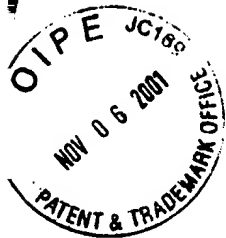
Sir:

Pursuant to the duty of disclosure under 37 C.F.R. §1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) and references cited therein.

These documents were cited in the attached German Office Action dated February 16, 2001 issued in a foreign counterpart application.

It is respectfully requested that the cited documents be considered by the Examiner, be made officially of record in the subject application and be listed on the face of any patent which may issue from this application.

A first Official Action has not yet issued for this application. It is respectfully urged that no fees are required for the Examiner's consideration of the documents listed in this Information Disclosure Statement. Therefore, if this Information Disclosure Statement should cross in the mail with a first Office Action on the merits or a Notice of Allowance for this



application, please consider the attached documents. Any fees that may be necessary to facilitate consideration of this Information Disclosure Statement, such as petition fees under 37 C.F.R. § 1.97(d), can be charged to Deposit Account No. 02-4300.

Respectfully submitted,

SMITH, GAMBRELL & RUSSELL, LLP

By: 

Robert G. Weilacher, Reg. No. 20,531  
1850 M Street, N.W., Suite 800  
Washington, D.C. 20036  
Telephone: (202) 659-2811  
Facsimile: (202) 263-4329

Dated: November 6, 2001

